# Reduction of Transverse SAW leakage on the Resonator based on Al/42° YX-LiTaO<sub>3</sub> substrate structure

LiTaO3 基板共振器の SAW 横方向漏洩の低減に関する検討

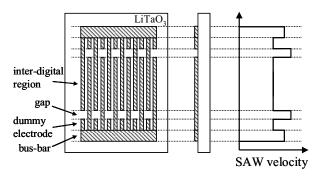
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# 1. Introduction

The transverse SAW leakage toward the bus-bar causes the increased insertion loss(IL) in leaky SAW resonators on a 42° YX-LiTaO<sub>3</sub>(42LT) substrate [1]. A narrow gap between the inter-digital electrode and the dummy electrode less than 0.25 $\lambda$  is effective to reduce the transverse SAW leakage [2]. However, it is difficult to realize such a narrow gap in the high frequency applications. This paper proposes the new resonator structure for the reduction of the transverse SAW leakage without narrowing the gap.

# 2. Reduction of Transverse SAW leakage

Fig.1 shows the schematic of the conventional SAW resonator structure, and the outline of SAW velocity on each region. Leaky SAW on a 42LT substrate has the waveguide in the velocity Regarding faster region. to the conventional structure, the SAW velocity on the gap and the bus-bar is faster than that on the inter-digital region. Therefore, the transverse SAW leakage occurs toward the bus-bar. Conversely, the transverse SAW leakage toward the bus-bar could be reduced by making the velocity on the bus-bar slower than that on the inter-digital region.



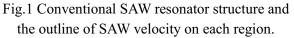


Fig.2 shows the schematic of the proposed SAW resonator structure, and the outline of SAW velocity

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on each region. The proposed SAW resonator consists of aluminum(Al) grating and deposited  $Ta_2O_5$  film on the outside of the inter-digital region. Since the density of  $Ta_2O_5$  is much higher than that of Al [3], the SAW velocity on the bus-bar could be slower than that on the inter-digital region.

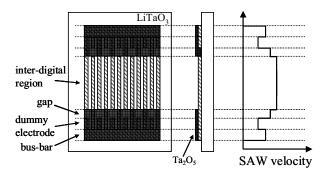


Fig.2 Proposed SAW resonator structure and the outline of SAW velocity on each region.

The effect of  $Ta_2O_5$  film for the structure was analyzed by FEMSDA [4]. Fig.3 shows the analytical results of variation of SAW velocity by  $Ta_2O_5$  film thickness. In the analysis, the relative Al thickness was set at 9% and the metallization ratio was set at 0.5.

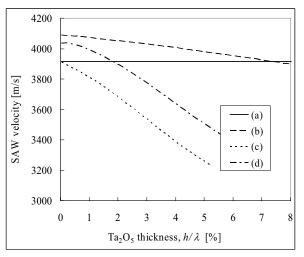


Fig.3 Variation of SAW velocity by Ta<sub>2</sub>O<sub>5</sub> film thickness. (a) Inter-digital region, (b) Gap, (c) Dummy electrode, and (d) Bus-bar.

It was confirmed that the SAW velocity on the bus-bar could be made slower by deposited  $Ta_2O_5$ film. This result suggests that Ta<sub>2</sub>O<sub>5</sub> film thickness of 2% is enough to reduce the transverse SAW leakage toward the bus-bar. On the other hand, Ta<sub>2</sub>O<sub>5</sub> film thickness of 7.5% is required to make the SAW velocity on the gap slower than that on the inter-digital region.

### 3. Experimental Results

The SAW resonators with the gap of  $0.5\lambda$  and  $Ta_2O_5$  film on the outside of the inter-digital region were fabricated on 42LT substrate. The design parameters are those shown in Table I. Fig. 4 shows the measured resonance characteristics by deposited Ta<sub>2</sub>O<sub>5</sub> film. Here, Ta<sub>2</sub>O<sub>5</sub> film thickness conditions are relative thickness of 3%, 2%, and without Ta<sub>2</sub>O<sub>5</sub> film, respectively. It is confirmed that IL of the resonator without Ta<sub>2</sub>O<sub>5</sub> film increases remarkably above the resonance frequency by the transverse SAW leakage. On the other hand, the increase of IL is reduced by deposited Ta<sub>2</sub>O<sub>5</sub> film without narrowing the gap. As the result of deposited  $Ta_2O_5$ film of 2%, IL is improved about 0.25 dB at  $f/f_r=1.01$ . In addition, it should be noted here that the measured conductance characteristic of the resonators with relative Ta<sub>2</sub>O<sub>5</sub> film thickness of 2% and 3% scarcely changes. This result suggests that the transverse SAW leakage toward the bus-bar could be suppressed by making the SAW velocity on the dummy electrode and the bus-bar slower than that on the inter-digital region.

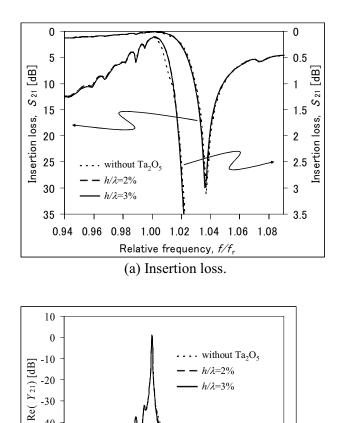
Number of IDT	75 pairs
Number of reflector	15 pairs
Metallization ratio	0.5
Aperture	15λ
Gap	0.5λ
Dummy length	1.5λ

#### 4. Conclusion

This paper proposed the new structure for reduction of the transverse SAW leakage toward the bus-bar in leaky SAW resonators on 42° YX-LiTaO<sub>3</sub> substrate without narrowing the gap. The transverse SAW leakage could be reduced by deposited  $Ta_2O_5$ film on the outside of inter-digital region.

The analytical result suggested that the SAW velocity on the bus-bar could be made slower than that on the inter-digital region by deposited  $Ta_2O_5$ film thickness of 2%.

Then the effect of the proposed structure was confirmed experimentally. The measured result showed that IL is improved about 0.25 dB at  $f/f_r = 1.01$  by deposited Ta<sub>2</sub>O<sub>5</sub> film thickness of 2%.



Relative frequency,  $f/f_r$ (b) Conductance characteristic.

0.98 1.00 1.02 1.04 1.06 1.08

 $h/\lambda=3\%$ 

Fig.4 Measured resonance characteristics by deposited Ta<sub>2</sub>O<sub>5</sub> film.

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#### References

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Conductance,

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